EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1114	((optical adj1 (cavit$3 via$1)) (vias holes apertures openings) (optical near1 (passag$2 pass adj1 through))) near12 reflect$4 same (waveguide$1 wave adj1 guide$1)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2009/02/02 17:46
L2	6446	waveguides same layers	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2009/02/02 17:46
L3	24403	(layer$1 substrat$2 backplane back adjl plane strip$2) near7 (flex$4 soft$3 polymer$3 kapto$1) same (waveguide$1 wave nearl guide$1)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2009/02/02 17:46
L4	50	L1 and L2 and L3	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2009/02/02 17:46
S1	35256	(waveguides wave nearl guides) same layers	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:04
S2	22601	(layer$1 substrat$2 backplane back adjl plane strip$2) near7 (flex$4 soft$3 polymer$3 kapto$1) same (waveguide$1 wave nearl guide$1)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:06
S3	38331	((optical adjl (cavit$3 via$1)) (vias holes apertures openings) (optical nearl (passag$3 pass adjl through))) same (waveguide$1 wave nearl guide$1) same layers	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:08

S4	213769	((optical adjl (cavit$3 via$1)) (vias holes apertures openings) (optical nearl (passag $3 oass adj1 through))) same (waveguide$1 wave nearl guide$1) same ((second adjl layer$1) layers)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:11
S5	219556	((optical adjl (cavit$3 via$1)) (vias holes apertures openings) (optical nearl (passag $3 pass adj1 through))) same (waveguide$1 wave nearl guide$1) same ((second adjl layer$1) layers)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:13
S6	12872275	((optical adjl (cavit$3 via$1)) (vias holes apertures openings) (optical nearl (passag $3 pass adjl through))) nearl2 reflect$5 same (waveguide$1 wave nearl guideS1)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:15
S7	8351858	((optical adjl (cavit$3 via$1)) (vias holes apertures openings) (optical nearl (passag $3 pass adj1 through))) nearl2 reflect$5 same (waveguide$1 wave nearl guide$1)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:16
S8	1035	((optical adj1 (cavit$3 via$1)) (vias holes apertures openings) (optical near1 (passag $2 pass adj1 through))) near12 reflect$4 same (waveguide$1 wave adj1 guide$1)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:20
S9	6010	waveguides same layers	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:21

S10	22601	(layer$1 substrat$2 backplane back adjl plane strip$2) near7 (flex$4 soft$3 polymer $3 kapto$1) same (waveguide$1 wave nearl guide$1)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:22
S11	49	S8 and S9 and S10	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:23
S12	1	"20030039455"	US-PGPUB; USPAT	OR	OFF	2008/03/24 20:24
S13	1	10/541188	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:38
S14	1	S13 and GaAs same (substrate$1 same semiconduct$4) and (emit$5 ld$1 laser$2) same GaAs and (transform$4 reflect$4) near12 semiconduct$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:44
S15	0	S13 and GaAs same substrate$1 same (emit $5 ld$1 laser$2) same (transform$4 reflect$4) near12 semiconduct$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:57
S16	0	S13 and GaAs same substrate$1 same (emit $5 ld$1 laser$2) same (transform$4 reflect$4) same semiconduct$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:58
S17	0	S12 and GaAs same (substrate$1 same semiconduct$4) and (emit$5 ld$1 laser$2) same GaAs and (transform$4 reflect$4) near12 semiconduct$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:58
S18	1	S12 and GaAs	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 20:58
S19	1	S12 and GaAs and (substrate$1 same semiconduct$4) and (emit$5 ld$1 laser$2) and GaAs and (transform$4 reflect$4 mirror$2 deflect$4) and semiconduct$4	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2008/03/24 21:00

| S20 | 1 | S12 and GaAs and (substrate$1 same semiconduct$4) and (emit$5 ld$1 laser$2) and GaAs and (transform$4 reflect$4 mirror$2 deflect$4) and semiconduct$4 and (si silic$4 sio$4) | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2008/03/24 21:01 |
| S21 | 1 | S13 and GaAs and (substrate$1 same semiconduct$4) and (emit$5 ld$1 laser$2) and GaAs and (transform$4 reflect$4 mirror$2 deflect$4) and semiconduct$4 and (si silic$4 sio$4) | US-PGPUB; USPAT; EPO; JPO; DERWENT | OR | OFF | 2008/03/24 21:21 |

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